

## Formation of miniature polymeric surface plasmon sensor chip using confined sessile drop technique.

Niigata Univ.<sup>1</sup>, Chulalongkorn Univ.<sup>2</sup>, Chiang Mai Univ.<sup>3</sup>, ° Supeera Nootchanat<sup>1</sup>

Wisansaya Jaikeandee<sup>1,2</sup>, Patrawadee Yaiwong<sup>1,3</sup>, Chutiparn Lertvachirapaiboon<sup>2</sup>

Kazunari Shinbo<sup>1</sup>, Keizo Kato<sup>1</sup>, Sanong Ekgasit<sup>2</sup> and Akira Baba<sup>1\*</sup>

E-mail: ababa@eng.niigata-u.ac.jp

In this work, we present a versatile method to fabricate a miniature surface plasmon resonance (SPR) sensor chip using confined sessile drop technique. The liquid photopolymer (NOA 61) was dropped on a circular polydimethylsiloxane (PDMS) substrates. Under equilibrium contention, hemispherical droplets were formed due to liquid spreading resistance at the edge of the substrate defined by Gibbs inequality equation [1]. After UV curing, the hemispherical optical prism was obtained. Miniature SPR sensor chips with Kretschmann configuration could be achieved by the deposition of a gold film with the thickness of 50 nm on the flat surface of the obtained prism [2]. The fabricated miniature SPR sensor chip was then mounted on a 3D-printed flow cell to complete the sensor module.

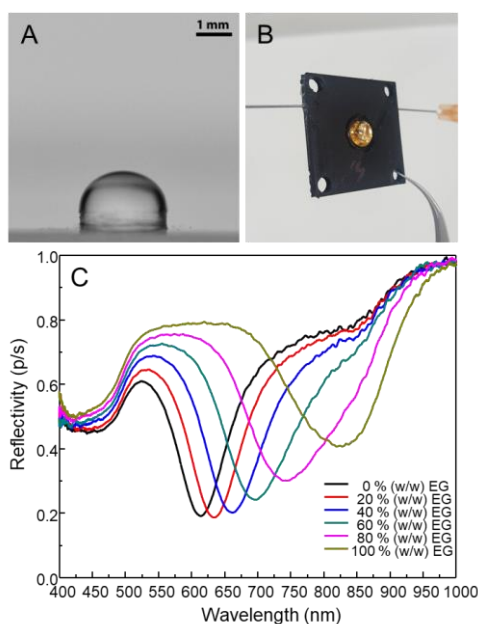


Figure 1 Digital photographs of (A) a sessile droplets of liquid polymer and (B) surface plasmon sensor chips attached to a 3D-printed flow cell. (C) Surface plasmon reflection spectra of water/ethylene glycol solution.

### References

- [1] Ekgasit, S.; Kaewmanee, N.; Jangtawee, P.; Thammacharoen, C.; Donphoongpri, M., ACS *Appl. Mater. Interfaces* **2016**, 8 (31), 20474-20482.
- [2] Pipatpanukul, C.; Takeya, S.; Baba, A.; Amarit, R.; Somboonkaew, A.; Sutapun, B.; Kitpoka, P.; Kunakorn, M.; Sriksirin, T., *Biosens. Bioelectron.* **2018**, 102, 267-275.